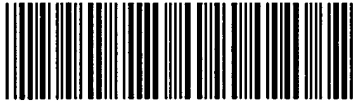


Search Notes

Application/Control No.

10/736,593

Examiner

Wai-Sing Louie

Applicant(s)/Patent under
Reexamination

USUDA ET AL.

Art Unit

2814

SEARCHED

| Class | Subclass | Date | Examiner |
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| 438/459 | | 11/19/2004 | DAW |

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
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| 438/458,459 | 11/19/2004 | DAW |
| Si, SiGe, strained, relax, bond, second substrate, flip chip | 11/19/2004 | DAW |
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